PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Li, et al.

Serial No.: 10/645,675

Confirmation No.: 8295

Filed:

August 20, 2003

For:

Methods of Reducing Plasma-Induced Damage

for Advanced Plasma CVD

Dielectrics

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Examiner:

Tuan H. Nguyen

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being tacsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9308 to the attention of the named Examiner, on the date below.

2/23/05

Date Signature

AMENDMENT AFTER ALLOWANCE

Following mailing of a Notice of Allowance on January 27, 2005, Applicants request entry of the following amendments. Amendments to the Specification are shown beginning page 2 of this paper. Amendments to the Claims begin on page 3 of this paper. Remarks begin on page 8 of this paper.

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